



**ELECTRONIC COPY**

LG749590932  
Report verification at igi.org



November 19, 2025

IGI Report Number **LG749590932**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **10.14 X 7.18 X 4.85 MM**

**GRADING RESULTS**

Carat Weight **3.10 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

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MODIFIED BRILLIANT**  
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**GRADING RESULTS**

Carat Weight **3.10 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

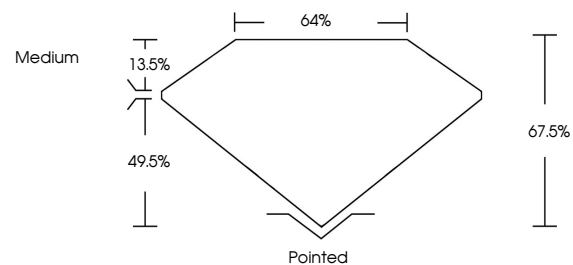
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG749590932**

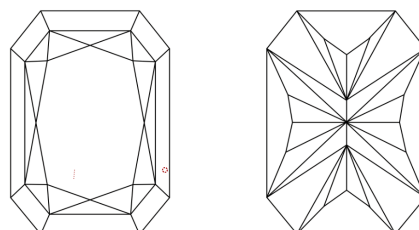
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

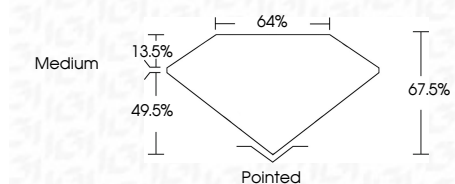
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT  
3.10 CARATS E  
Color Grade E  
Clarity Grade VS 1  
Table 13.5%  
Depth 49.5%  
Width 64%  
Height 67.5%  
Medium  
Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG749590932  
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